IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Art Unit:

Not assigned

Terunao HANAOKA et al.

Examiner: Not assigned

Serial No: Not assigned

Filed: March 17, 2004

For:

Semiconductor Wafer, Semiconductor Device and Method for Manufacturing Same, Circuit Board, and

Electronic Apparatus

TRANSMITTAL OF INFORMATION DISCLOSURE **STATEMENT**

Mail Stop PATENT APPLICATION Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

The information disclosure statement submitted herewith is being filed concurrently with the subject application [37 C.F.R. § 1.97(b)] and contains no items of information cited in any communication from a foreign patent office in a counterpart foreign application [37 C.F.R. § 1.97(e)(1)].

If it should be determined that for any reason either an insufficient or excessive fee has been paid, please charge any insufficiency or credit any overpayment necessary to ensure consideration of the information disclosure statement for the above-identified application to Deposit Account No. 50-1314. A copy of this paper is enclosed.

Respectfully submitted.

HOGAN

Date: March 17, 2004

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FORM PTO-1449			Docket Number (Optional) 81754.0114		Application Number Not assigned	
INFORMATION DISCLOSURE CITATION IN AN APPLICATION			Applicant Terunao HANAOKA et al.			
(Use several sheets if necessary)			Filing Date March 17, 2004		Group Art Unit Not assigned	
U.S. PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	6,323,542	11/27/01	Hashimoto			
	US 2002/0008320 A1	01/24/02	Kuwabara et al.			
						
:						
FOREIGN PATENT DOCUMENTS						
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION (YES/NO)
	11-297873	10/29/99	Japan			Abstract
	2003-209137	07/25/03	Japan			Abstract
	WO00/55898	09/21/00	PCT			Abstract
			•			
			100			
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)						
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		ATE 001:0:==	DED.			
EXAMINER DATE CONSIDERED						
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.						